Notice of References Cited Application/Control No. 09/842,769 Examiner Lynette T. Umez-Eronini U.S. PATENT DOCUMENTS * Document Number Country Code-Number-Kind Code Date MM-YYYY Name Applicant(s)/Patent Under Reexamination HAGIHARA ET AL. Page 1 of 1 Classification

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— ppy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a)) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.